



#15/D  
8-26-00  
Robert  
PATENT *amdt*

THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:**

Gurtej S. Sandhu

**Serial No.:** 09/023,146

**Filed:** February 12, 1998

**For:** TUNGSTEN SILICIDE (WSIx)  
DEPOSITION PROCESS FOR  
SEMICONDUCTOR MANUFACTURE

**Examiner:** T. Dang

**Group Art Unit:** 2823

**Attorney Docket No.:** 3369.1US  
(91-365-RE)

CERTIFICATE OF MAILING

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AMENDMENT

Box Non Fee Amendment  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed May 12, 2000, the three-month shortened statutory period for response to which expires on August 12, 2000.

RECEIVED  
AUG 24 2000  
TECHNOLOGY CENTER 2800